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Bib Data Sheet

CONFIRMATION NO. 2592

SERIAL NUMBER 10/708,593	FILING DATE 03/12/2004  RULE	CLASS 438	GROUP ART UNIT 2823	ATTORNEY DOCKET NO. 040091
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\*\* CONTINUING DATA \*\*\*\*\*

none ME

\*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2003-84056 03/26/2003 ME

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 05/20/2004

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged	JAPAN	4	15 6	2 1
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## TITLE

Method for Manufacturing Buried Insulating Layer Type Single Crystal Silicon Carbide Substrate

☐ All Fees

<b>FILING FEE</b>  <b>RECEIVED</b> 1096	<b>FEES:</b> Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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